## Amendments to the Claims

1-14. (Cancelled).

an alignment layer comprising constituent materials, the constituent materials having a stoichiometric relationship configured to provide a given pretilt angle, wherein the stoichiometric relationship is configured by introducing an amount of material to adjust a stoichiometric ratio of the constituent materials, the amount determined to provide the given pretilt angle the constituent materials having a stoichiometric ratio adjusted to provide a given pretilt angle; and

liquid crystal material in contact with the alignment layer.

- 16. (Original): The device as recited in claim 15, wherein the material includes  $SiC_x$  wherein x is adjusted to provide the stoichiometric relationship.
- 17. (Previously Presented): The device as recited in claim 15, wherein the material includes silicon oxynitride.
- 18. (Previously Presented): The device as recited in claim 15, wherein the material includes a material having Pi-electrons.
- 19. (Préviously Presented): The device as recited in claim 15, wherein the alignment layer includes a tilted homeotropic alignment layer.

20. (Currently Amended): A liquid crystal display device, comprising:

an ion beam-irradiated alignment layer formed on a substrate, the alignment layer

comprising constituent materials, the constituent materials having a stoichiometric

relationship configured to provide a given pretilt angle, wherein a non-rubbing ion bean

irradiation is employed on the surface of the alignment layer to control the uniformity of

the pretilt angle having a stoichiometric ratio adjusted to provide an adjusted pretilt angle;

and

liquid crystal material in contact with the alignment layer.

21. (New): A liquid crystal display device, comprising:

an alignment layer comprising constituent materials, the alignment layer having a preexisting pretilt angle;

an amount of material for adjusting a stoichiometric ratio of the constituent materials of the alignment layer, wherein the amount is determined to provide a given pretilt angle of the alignment layer different than the preexisting pretilt angle of the alignment layer; and

liquid crystal material in contact with the alignment layer.